

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Yasuhiro WAKIZAKA et al.**

Serial Number: **Not Yet Assigned**
(§371 of international application No. PCT/JP03/04114)

Filed: **November 16, 2004**

For: **METHOD FOR FORMING MULTILAYER CIRCUIT STRUCTURE AND
SUBSTRATE HAVING MULTILAYER CIRCUIT STRUCTURE**

Attorney Docket No.: **042978**

Customer No.: **38834**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

November 16, 2004

Sir:

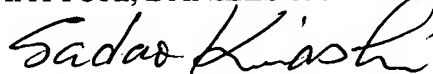
In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosures: PTO-1449; References (6) and international search report.

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 042978	Serial No. New Appln. 10/514 421
	Applicant(s): Yasuhiro WAKIZAKA et al.	
	Filing Date: November 16, 2004	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
AA	8-125307	05/17/96	Japan	Yes. Cited in the int'l. search report.
AB	2000-286559	10/13/00	Japan	Yes. Cited in the int'l. search report.
AC	63-146486	06/18/88	Japan	No. Cited in the int'l. search report.
AD	63-211796	09/02/88	Japan	No. Cited in the int'l. search report.
AE	2002-30452	01/31/02	Japan	Yes. Cited in the int'l. search report.
AF	10-135638	05/22/98	Japan	Yes. Cited in the int'l. search report.

OTHER DOCUMENTS

Examiner	Date Considered	